

IFW

03500.015383.1

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:

HIROKAZU OTOSHI ET AL.

Application No.: 10/627,603

Filed: July 28, 2003

For: APPARATUS AND METHOD
FOR FORMING DEPOSITED
FILM

)
:
Examiner: Timothy H. Meeks
)
:
Group Art Unit: 1762
)
:
)
:
)
:
)
:
May 6, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a.) Introductory Comments

In response to the Office Action of February 10, 2005, kindly amend the
application as follows.